

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 9938

Hiroshi TAKANASHI et al.

Docket No. 2001 0476

Serial No. 09/838,118

Group Art Unit 1752

Filed April 20, 2001

Examiner S. Lee

NEGATIVE-WORKING PHOTOSENSITIVE RESIN COMPOSITION AND PHOTOSENSITIVE RESIN PLATE USING THE SAME

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to the provisions of 37 CFR 1.56, 1.97 and 1.98, Applicants request consideration of the references listed on attached form PTO-1449.

A legible copy of each reference listed on the form PTO-1449 and each U.S. patent application listed below is enclosed.

1a. [X] This Information Disclosure Statement is submitted:

within three months of the filing date (or of entry into the National Stage) of the above-entitled application, or

before the mailing of a first Office Action on the merits or the mailing of a first Office Action after the filing of an RCE,

and thus no certification and/or fee is required.

1b. [] This Information Disclosure Statement is submitted

after the events of above paragraph 1a and prior to the mailing date of a final Office Action or a Notice of Allowance or an action which otherwise closes prosecution in the application, and thus: (1) [] the certification of paragraph 2 below is provided, or (2) [] the fee of \$180.00 specified in 37 CFR 1.17(p) is enclosed. [] This Information Disclosure Statement is submitted: after the mailing date of a final Office Action or Notice of Allowance or action which otherwise closes prosecution in the application, and prior to payment of the issue fee, and thus: the certification of paragraph 2 below is provided, and the fee of \$180.00 specified in 37 CFR 1.17(p) is enclosed. It is hereby certified a. [] that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Statement, or b. [] that no item of information contained in the Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application and, to the knowledge of the person signing the certification after making reasonable inquiry, was known to any individual designated in §1.56(c) more than three months prior to the filing of the Statement. 3. [] Consideration of the following list of additional information (including any copending or abandoned U.S. application, prior uses and/or sales, etc.) is requested.

f a

1c.

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is made to:

a. []

a full or partial English language translation submitted herewith,

For each non-English language reference listed on the attached form PTO-1449, reference

- b. [] a foreign patent office search report (in the English language) submitted herewith,
- c. [] the concise explanation contained in the specification of the present application at page,
- d. [X] the concise explanation set forth in the attached English language abstract,
- e. [X] the concise explanation set forth below or on a separate sheet attached to the reference:
- 1. Enclosed is a JPO Office Action (=Notification of Reasons for Rejection; Reasons 1 and 2) for the corresponding Japanese Patent Application No. 10-071513 (Dispatch date: October 16, 2003, Drafting date: October 14, 2003), an English translation thereof, and References 1-5 and English abstracts thereof cited in the Office Action.
- 2. Assignee of this application filed an argument on December 15, 2003 at the JPO for the Notification of Reasons for Rejection.
- 3. The Decision of Rejection by the JPO was dispatched on January 16, 2004, indicating the application should be rejected for Reason 1 as described in the Notification of Reasons for Rejection drafted on October 14, 2003. No additional references were cited in this Decision. Enclosed is the Decision of Rejection and an English translation thereof.
- 4. Assignee filed an Appeal Brief on June 11, 2004 and an Amendment on March 17, 2004 for the Decision of Rejection.
- 5. The Japanese application is now under examination.
- 5. [] A foreign patent office search report citing one or more of the references is enclosed.

Respectfully submitted,

Hiroshi TAKANASHI et al.

Ву\_

Matthew M. Jacob Registration No. 25,154

Attorney for Applicants

MJ/da Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 June 14, 2004

Sheet 1 of 1								
FORM, PTO 1449 (modified) JUN 1 4 2004 2		أبيو	ATTY DOCKET NO. 2001_0476	SERIA 09/83	L NO. 8,118		·	
U.S. DEPARTMENT OF COMMERCE PATENT AND TRACEMARK OFFICE TRADE.  LIST OF REFERENCES CITED BY APPLICANT(S)				APPLICANT Hiroshi TAKANASHI et al.				
(Use several sheets if necessary)  Date Submitted to PTO: June 14, 2004				FILING DATE April 20, 2001		GROUP 1752		
U.S. PATENT DOCUMENTS								
*EVANINED		DOCUMENT			CLASS	SUBSIAGE	EILING D	
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	. NAME	CLASS	SUBCLASS	FILING DA APPROPE	
	AA							
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FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	OCCUMENT DATE COUNTRY CLASS SUBCLASS T NUMBER		TRANSLA YES	ATION NO		
	AJ	10-10742	1/1998	Japan			abstract	
	AK	08-220766	8/1996	Japan			abstract	
	AL	09-034110	2/1997	Japan			abstract	
	AM	09-288974	11/1997	Japan			abstract	
	AN	09-025360	1/1997	Japan			abstract	
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AO							
	AP							
	AQ							
EXAMINER				DATE CONSIDERED				